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INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application No.	10/751,328
				Filing Date	December 31, 2003
				First Named Inventor	Feng Xie <i>et al.</i>
				Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
Sheet	1	of	1	Attorney Docket Number	23564-08653

U.S. PATENT DOCUMENTS				
Examiner Initials*	Cite No. ¹	Document No. Number - Kind Code ² (if known)	Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document

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FOREIGN PATENT DOCUMENTS					
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OTHER REFERENCES - NON-PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ⁶
SB	C1	REEVES, William T., et al., "Approximate and Probabilistic Algorithms for Shading and Rendering Structured Particle Systems," Siggraph '85, Vol. 19, July 1985, No. 3, pp. 313-322.	
SB	C2	DUFF, Tom, et al., "Compositing 3-D Rendered Images," Siggraph '85, Vol. 19, July 1985, No. 3, pp. 41-44.	
SB	C3	REEVES, William T., "Particle Systems__ Technique for Modeling a Class of Fuzzy Objects," Computer Graphics, Vol. 17, No. 3, July 1983, pp. 359-376	

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Examiner Signature		Date Considered	1-10-2006
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